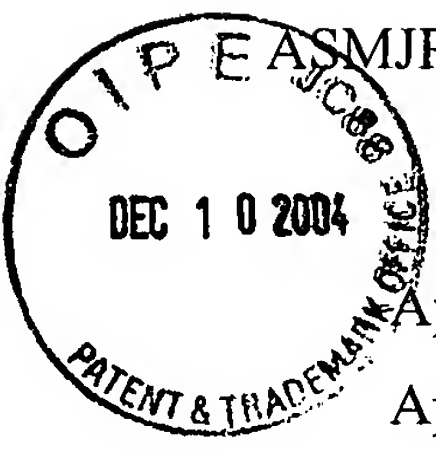


IFW

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Tsuji, et al.
Appl. No. : 10/657,416
Filed : September 8, 2003
For : INTERLAYER INSULATION
FILM USED FOR MULTILAYER
INTERCONNECT OF
SEMICONDUCTOR ...
INTEGRATED
Examiner : William C. Vesperman
Group Art Unit : 2813

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

December 7, 2004

(Date)

Katsuhiro Arai, Reg. No. 43,315

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the communication from the Examiner mailed November 2, 2004. In response to the election/restriction requirement set forth in the communication, Applicant elects to prosecute Group I, Claims 1-12 (Class 438, subclass +1). This election is made without traverse.

Should the Examiner have any questions concerning this election, the Examiner is respectfully invited to contact the undersigned at the telephone number appearing below. Please charge any fees, including any fees for extension of time to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: December 7, 2004

By:

Katsuhiro Arai
Registration No. 43,315
Attorney of Record
Customer No. 20,995
(949) 760-0404